



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/677,478
Filing Date October 2, 2000
Inventor Guy T. Blalock et al.
Assignee Micron Technology, Inc.
Group Art Unit 1765
Examiner Lan Vinh
Attorney's Docket No. MI22-1544
Customer No. 021567
Title: Plasma Etching Methods

RESPONSE TO JANUARY 26, 2006 FINAL OFFICE ACTION
ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION (RCE)

To: Mail Stop RCE
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

From: D. Brent Kenady
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Wells St. John P.S.
601 West First Avenue, Suite 1300
Spokane, WA 99201-3828

Responsive to the Final Office Action dated September 16, 2005,
Applicants amend and remark as follows:

AMENDMENTS

Underlines indicate insertions and ~~strikeouts~~ indicate deletions.

06/29/2006 RFEKADU1 00000031 09677478

03 FC:1202

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